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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(Case No. 213.002-D1-US)In the Application of: **Ye et al.**Serial No: **10/646,313**Filed: **August 22, 2003**Title: **System and Method for Lithography  
Process Monitoring and Control**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450) **U.S. Patent 6,806,456**  
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Date

Michiko Sites

(name of person signing certificate)

Michiko Sites

Signature

**NOTIFICATION OF CHANGE OF SMALL ENTITY STATUS**

Dear Sir:

Pursuant to 37 CFR §1.27(g)(2), the above-referenced patent/application is no longer entitled to small entity status.

Respectfully submitted,



Date: April 19, 2007

Neil A. Steinberg, Reg. No. 34,735  
Telephone No. 650-968-8079